



Docket No. 740756-2154

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of:)
Shunpei YAMAZAKI et al.)
Application Serial No.: 09/580,485) Group Art Unit: 2813
Filed: May 30, 2000) Examiner: A. Sarkar
For: METHOD FOR MANUFACTURING)
AN ELECTRO-OPTICAL DEVICE) Date: August 20, 2001

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AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Responsive to the Office Action dated **March 20, 2001**, the period for response having been extended two (2) months to **August 20, 2001**, the following amendments and remarks are submitted in connection with the above-identified application.

IN THE SPECIFICATION:

Please amend the specification as follows. While the amendments are presented below in their amended form, they are outlined in an Attachment to the Amendment using the conventional indication method of bracketing and underlining.

On page 1, please replace the first full paragraph with the following.

Techniques of forming a TFT on a substrate have been widely progressing in recent years, and developments of applications to an active matrix type display device are advancing. In particular, a TFT using a polysilicon film has a higher electric field effect mobility (also referred to as mobility) than a TFT using a conventional amorphous silicon film, and high speed operation is therefore possible. As a result, it becomes possible to perform pixel control, conventionally performed by a driver circuit external to the substrate, by a driver circuit formed on the same substrate as the pixel.